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## TRANSMISSION OK

TX/RX NO	3569
CONNECTION TEL	7038729319
CONNECTION ID	
ST. TIME	05/13 17:01
USAGE T	03'40
PGS. SENT	13
RESULT	OK

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
Attention: L. Cruz  
Art Unit: 2827

Re: Y. YAMAGUCHI, et al. – Application No.: 09/811,401  
Attorney Docket No.: 500.39919X00

**SUBMISSION OF AMENDMENT**  
**AND PETITION FOR EXTENSION OF TIME**

Sir:

Applicant hereby submits the attached "Amendment After Final Rejection" (11 pgs) and an "Explanation with drawings" (1 p), in the above-identified application.

**CERTIFICATE OF TRANSMISSION:**

I hereby certify that the attached "Amendment After Final Rejection" (11 pgs), and an "Explanation with drawings" (1 p) are being formally filed in the USPTO via Group 2800 Facsimile No. 703-872-9319 on May 13, 2003.

R. J. - 1. 6/20/03

500.39919X00  
Response Under 37 CFR 1.116  
Expedited Procedure  
Group No. 2827

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Y. YAMAGUCHI, et al  
Application No.: 09/811,401  
Filed: March 20, 2001  
For: SEMICONDUCTOR DEVICE AND METHOD FOR  
MANUFACTURING THE SAME AND SEMICONDUCTOR  
DEVICE-MOUNTED STRUCTURE  
Art Unit: 2827  
Examiner: L. Cruz

**AMENDMENT AFTER FINAL REJECTION**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

May 13, 2003

Sir:

In response to the Final Office Action dated February 13, 2003, please amend  
the above-identified application as follows:

**IN THE CLAIMS:**

Please amend claim 2 as follows:

2. ( Twice Amended) A semiconductor device according to Claim 1, wherein  
a protuberant portion is formed in a surrounding part connected to the inclined edge  
portion of the stress relaxation layer, said protuberant portion having a height which  
is slightly higher than a height of a flat portion of the stress relaxation layer, and a  
deflected portion is formed in the wiring existing on said protuberant portion.